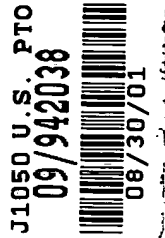


#4 / IDS
2-1-02
Mollen

Docket: 740819-637

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re New Patent Application of)
Yoshihiro MORI et al.)
Japanese Priority Application No. 2000-265284) Attn: Applications
Japanese Priority Date: September 1, 2001) Branch
For: CAPACITOR AND METHOD FOR)
FABRICATING SEMICONDUCTOR)
DEVICE) Date: August 30, 2001



INFORMATION DISCLOSURE STATEMENT

Honorable Commissioner for Patents
Washington, D.C. 20231


Sir:

In accordance with the provisions of 37 C.F.R. 1.56 and 37 C.F.R. 1.97-1.99, it is requested that the references listed on the attached Form PTO-1449 be made of record in the above-identified application.

At least some of the references listed on the attached Form PTO-1449 are discussed in the specification of the subject application.

Copies of the references are submitted herewith in accordance with 37 C.F.R. 1.98(a).

Respectfully submitted,


Eric J. Robinson
Registration No. 38,285

NIXON PEABODY LLP
8180 Greensboro Drive, Suite 800
McLean, Virginia 22102
(703) 790-9110